



500.014055.

original for
Amendment
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
NOBUHIRO ITO ET AL.)
Appln. No.: 09/413,774)
Filed: October 7, 1999)
For: ELECTRON BEAM)
APPARATUS AND SPACER)
Examiner: S. Roy
Group Art Unit: 2879
February 19, 2003

The Commissioner for Patents
Washington, D.C. 20231

AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

This Amendment And Response To Office Action is filed in response to the Office Action (Paper No. 17) of November 18, 2002, which set forth a shortened statutory period for reply ending on Tuesday, February 18, 2003 (the Patent and Trademark Office was closed on that date).

In response to the Office Action, please amend the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to:
Commissioner for Patents, Washington, D.C. 20231 on

February 19, 2003

(Date of Deposit)

Frank A. DeLucia (Reg. No. 42,476)

(Name of Attorney for Applicants)

Signature

February 19, 2003

Date of Signature

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